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	Applicant(s) Seung-Don CHOI, et al	
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U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS							
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FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		7-192721	7-28-1995	JAPAN				
		2000-173599	6-23-2000	JAPAN				
		2000-40505	2-8-2000	JAPAN				
		10-255839	9-25-1998	JAPAN				

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
		PCT International Search Report; International Application No. PCT/KR2004/001897; International Filing Date: July 28, 2004

EXAMINER /Patricia Davis/	DATE CONSIDERED 02/26/2009
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